IRN



In re the Application of: MARUTA, Yukio, et al.

Group Art Unit: 2822

Serial No.: 10/708,587

Examiner: Kevin M. PICARDAT

Filed: March 12, 2004

P.T.O. Confirmation No.: 2586

FOR: METHOD AND DEVICE FOR CUTTING WIRE FORMED ON SEMICONDUCTOR SUBSTRATE

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 28, 2005

Sir:

In response to the Office Action dated **June 30, 2005**, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.